Special Issue

Microstructured Sensors: From Design to Application

Message from the Guest Editors

With the development and upgrading of information technology and the health industry, functional sensors have become increasingly vital for ensuring individuals' quality of life and health. Sensors such as optical, chemical, and biological sensors play a crucial role in this regard, demanding new advancements in sensor design and production. Microstructured sensors have emerged as a key solution, as they offer enhanced sensitivity, stability, specificity, and even service life, which make them of great significance in fields such as biomedical engineering, environmental monitoring, and industrial process control.

"Microstructured Sensors: from Design to Application" encompasses diverse topics, including, but not limited to, the design, fabrication, characterization, and application of microstructured sensors. We warmly encourage the submission of original research articles, reviews, and communications that address the latest advances and challenges in this traditional but vigorous field. We look forward to receiving your contributions and hope that this Special Issue will serve as a valuable resource for researchers, engineers, and industry professionals alike.

Guest Editors

Dr. Mingliang Li

Department of Chemistry, The University of Hong Kong, Hong Kong 999077, China

Dr. Ziwei Li

Hunan Institute of Optoelectronic Integration, College of Materials Science and Engineering, Hunan University, Changsha 410082, China

Deadline for manuscript submissions

closed (10 October 2024)



Micromachines

an Open Access Journal by MDPI

Impact Factor 3.0 CiteScore 6.0 Indexed in PubMed



mdpi.com/si/184442

Micromachines
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
micromachines@mdpi.com

mdpi.com/journal/ micromachines





an Open Access Journal by MDPI

Impact Factor 3.0 CiteScore 6.0 Indexed in PubMed



About the Journal

Message from the Editor-in-Chief

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

Editor-in-Chief

Prof. Dr. Ai-Qun Liu

- 1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China
- 2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

Author Benefits

High Visibility:

indexed within Scopus, SCIE (Web of Science), PubMed, PMC, Ei Compendex, dblp, and other databases.

Journal Rank:

JCR - Q2 (Instruments and Instrumentation) / CiteScore - Q1 (Mechanical Engineering)

Rapid Publication:

manuscripts are peer-reviewed and a first decision is provided to authors approximately 17.2 days after submission; acceptance to publication is undertaken in 1.9 days (median values for papers published in this journal in the first half of 2025).

